Search Notes



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Examiner

Applicant(s)/Patent Under Reexamination
TAKAMIZAWA ET AL.

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Art Unit

Robert M Kunemund

1792

SEARCHED

Class	Subclass	Date	Examiner
117	94,95,96, 105	3/10/08	RMK

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Search Notes	Date	Examiner
west: etch, bake, dop, silicon substrate	3/10/08	RMK

INTERFERENCE SEARCH

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